

## Band diagram of a $p$ - $n$ junction between Mott-insulator $\text{LaMnO}_3$ and band-insulator $\text{Nb:SrTiO}_3$ determined by X-ray photoemission spectroscopy

Miho Kitamura<sup>1,2,\*</sup>, Masaki Kobayashi<sup>2</sup>, Enju Sakai<sup>2</sup>, Koji Horiba<sup>2</sup>, Ryota Takahashi<sup>3</sup>,  
Mikk Lippmaa<sup>3</sup>, Hiroshi Fujioka<sup>1</sup>, and Hiroshi Kumigashira<sup>2</sup>

<sup>1</sup>Institute of Industrial Science, the University of Tokyo, 4-6-1 Komaba, Meguro-ku,  
Tokyo 153-8505, Japan

<sup>2</sup>Photon Factory, KEK, 1-1 Oho, Tsukuba 305-0801, Japan

<sup>3</sup>Institute for Solid State Physics, the University of Tokyo, Kashiwa 277-8581, Japan

### 1 Introduction

Heterointerfaces of transition metal oxides have attracted considerable interest because of their unusual electronic and/or magnetic properties. One interesting aspect of these heterointerfaces, from the point of view of fundamental studies and device applications is the modulation of ferromagnetism [1] and the appearance of new optical transitions between interface states [2] in superlattices consisting of a “ $p$ -type” Mott-insulator  $\text{LaMnO}_3$  (LMO) and  $n$ -type semiconductor  $\text{SrTiO}_3$  (STO). For understanding these novel phenomena, it is indispensable to elucidate the band diagram of the interface. In this study, we have investigated the band profile of LMO/Nb-doped STO (Nb:STO)  $p$ - $n$  junctions at different donor concentrations using X-ray photoemission spectroscopy.

### 2 Experiment

Epitaxial LMO films with various thicknesses were grown on 0.05 wt. % and 0.5 wt. % Nb-doped STO substrates by laser molecular beam epitaxy. After thin film growth, samples were transferred to an XPS chamber without air exposure and XPS measurements were performed using a VG-Scienta R3000 analyzer with a monochromatized  $\text{Al K}\alpha$  X-ray source ( $h\nu = 1486.6$  eV).

### 3 Results and Discussion

Figure 1 shows Ti  $2p$  core level spectra of Nb:STO covered by a LMO overlayer. The positions of the Ti  $2p$  core levels shift to lower binding energies with increasing LMO overlayer thickness for both junctions, irrespective of the Nb doping concentration. These energy shifts correspond to the built-in potentials formed in Nb:STO due to band bending. Notably, the energy shifts change depending on the donor concentration, being  $0.55 \pm 0.05$  eV for Nb: 0.05 wt. % and  $0.25 \pm 0.05$  eV for Nb: 0.5 wt. %. Based on the  $p$ - $n$  junction model of conventional semiconductors, the total built-in potential of a LMO/Nb:STO junction was estimated to be 0.63 eV and the hole density in the LMO film was  $6.0 \times 10^{20} \text{ cm}^{-3}$ . These values are consistent with previous results obtained from transport properties [3,4]. The results indicate that the junction properties of a LMO/Nb:STO heterointerface can be accurately described in the framework of the  $p$ - $n$  junction model.

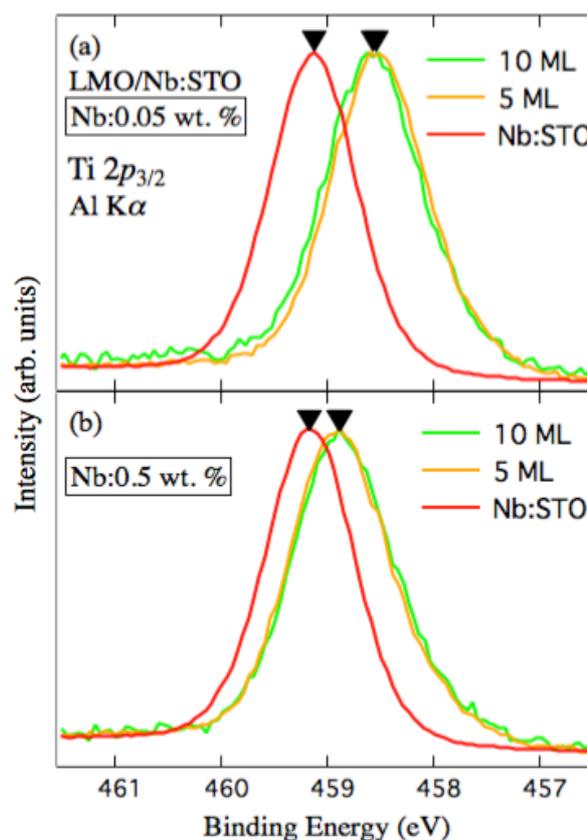


Fig. 1 Ti  $2p$  core-level photoemission spectra of LMO/Nb:STO heterointerface. (a) Nb: 0.05 wt. %, (b) Nb: 0.5 wt. %

### References

- [1] J. Garcia-Barriocanal *et al.*, *Adv. Mater.* **22**, 627 (2010).
- [2] X. Zhai *et al.*, *Adv. Mater.* **22**, 1136 (2010).
- [3] M. Nakamura *et al.*, *Phys. Rev. B* **82**, 201101(R) (2010).
- [4] J. Fujioka *et al.*, *J. Appl. Phys.* **111**, 016107 (2012).

\* mkita@iis.u-tokyo.ac.jp